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Application Number	10591718
Filing Date	2006-09-05
First Named Inventor	Keita Ishiduka
Art Unit	1795
Examiner Name	Connie P. Johnson
Attorney Docket Number	1608-7 PCT/US

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	3	HINSBERG W ET AL: "Liquid immersion lithography - Evaluation of resist issues" PROCEEDINGS OF THE SPIE, SPIE, BELLINGHAM, VA; US, vol.5376, 1 February 2004 (2004-02-01), pages 21-33, XP002477117	<input type="checkbox"/>

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